



**ELECTRONIC COPY**

LG750515654  
Report verification at igi.org



February 16, 2026  
IGI Report Number **LG750515654**  
Description **LABORATORY GROWN DIAMOND**  
Shape and Cutting Style **PEAR BRILLIANT**  
Measurements **19.18 X 11.98 X 7.31 MM**  
**GRADING RESULTS**  
Carat Weight **10.03 CARATS**  
Color Grade **F**  
Clarity Grade **VVS 2**

February 16, 2026  
IGI Report Number **LG750515654**  
Description **LABORATORY GROWN DIAMOND**  
Shape and Cutting Style **PEAR BRILLIANT**  
Measurements **19.18 X 11.98 X 7.31 MM**

**GRADING RESULTS**

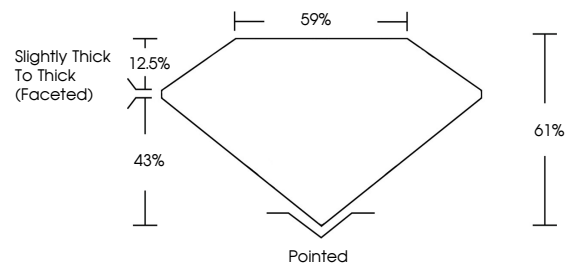
Carat Weight **10.03 CARATS**  
Color Grade **F**  
Clarity Grade **VVS 2**

**ADDITIONAL GRADING INFORMATION**

Polish **EXCELLENT**  
Symmetry **EXCELLENT**  
Fluorescence **NONE**  
Inscription(s) **IGI LG750515654**

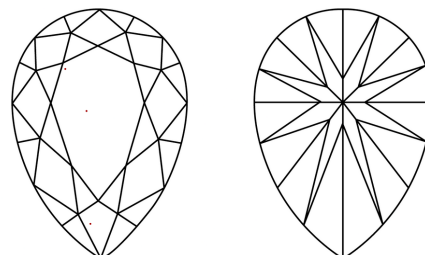
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

**PROPORTIONS**



Sample Image Used

**CLARITY CHARACTERISTICS**



**KEY TO SYMBOLS**

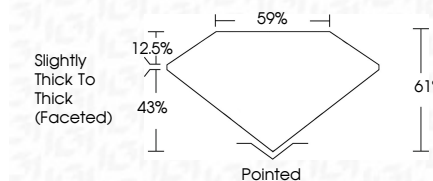
Red symbols indicate internal characteristics.  
Green symbols indicate external characteristics.

**COLOR**

D E F G H I J Faint Very Light Light

**CLARITY**

FL	IF	VS <sup>1-2</sup>	VS <sup>1-2</sup>	SI <sup>1-2</sup>	I <sup>1-3</sup>
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included



**ADDITIONAL GRADING INFORMATION**

Polish **EXCELLENT**  
Symmetry **EXCELLENT**  
Fluorescence **NONE**  
Inscription(s) **IGI LG750515654**  
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa



February 16, 2026  
IGI Report No LG750515654  
**PEAR BRILLIANT**  
19.18 X 11.98 X 7.31 MM  
10.03 CARATS  
Color Grade **F**  
Clarity Grade **VVS 2**  
Table **61%**  
Depth **59%**  
Girdle **Slightly Thick To Thick (Faceted)**  
Culet **Pointed**  
Polish **EXCELLENT**  
Symmetry **EXCELLENT**  
Fluorescence **NONE**  
Inscription(s) **IGI LG750515654**  
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa